

SEP 13 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100191)

Applicant: Schroeder et al.

Application No. 10/660,379

Filed: September 11, 2003

For: CHEMICAL-MECHANICAL
POLISHING COMPOSITION
AND METHOD FOR USING
THE SAMEExaminer: George A. Goudreau
Art Unit: 1763Certificate of Facsimile TransmissionI, Mariejose Monsalve, hereby certify that this
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RESPONSE TO OFFICE ACTIONMail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Office Action dated July 14, 2006, please enter the following
amendments and consider the following remarks.

*Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.*

Remarks/Arguments begin on page 8 of this paper.

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